



PATENT  
Attorney Docket No. 04173.0441

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Hisashi Kaneko et al. ) Group Art Unit: 2123  
)  
Application No.: 10/757,415 ) Examiner: SHARON, Ayal I.  
)  
Filed: January 15, 2004 ) Confirmation No.: 3384  
)  
For: SIMULATION CIRCUIT PATTERN )  
EVALUATION METHOD, )  
MANUFACTURING METHOD OF )  
SEMICONDUCTOR INTEGRATED )  
CIRCUIT, TEST SUBSTRATE, )  
AND TEST SUBSTRATE GROUP )

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed December 19, 2006, the period to respond to which extending through March 19, 2007, Applicants request reconsideration in view of the following:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendment section of this paper.